

Notice of References Cited	Application/Control No. 10/669,410	Applicant(s)/Patent Under Reexamination LIE ET AL.	
	Examiner Marivelisse Santiago-Cordero	Art Unit 2617	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0193107	12-2002	Nascimento, Oswaldo L. do JR.	455/426
*	B	US-4,959,851	09-1990	Tobolski et al.	455/74.1
*	C	US-2002/0155819	10-2002	Trombatore, Charles Paul	455/74.1
*	D	US-2003/0017854	01-2003	Avitan, Asher	455/564
*	E	US-5,983,098	11-1999	Gerszberg et al.	455/426.1
*	F	US-2004/0097198	05-2004	Chen, Stephen	455/074.1
*	G	US-2004/0203481	10-2004	Park et al.	455/074.1
*	H	US-2006/0111151	05-2006	Lie et al.	455/565
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
	W	
	X	

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